

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(etching and depositing same passivation and partially near3 etching same passivation and etching near3 cycle).clm.	USPAT	OR	OFF	2006/07/24 08:38
L2	0	(etching and depositing same passivation and partially near3 etching same passivation and etching near3 cycle).clm.	US-PGPUB; USPAT	OR	OFF	2006/07/24 08:38